OVERVIEW OF THE MICROSCOPE OBJECTIVE

by

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STATEMENT BY AUTHOR

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DEDICATION

To my grandfather, Liming Tang.

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ABSTRACT

Microscopes are widely used in research and industry. The objective lens is the most significant part of the microscope. Some characteristics and different types of microscope objectives are discussed in this thesis. The markings on the objective indicate some main optical characteristics. However, it is not always possible to know the materials, the radius or the thickness of each surface in an objective lens and it is not easy to simulate an objective without this data. In this thesis, we build a first order model which can simulate a refractive microscope objective when the magnification and numerical aperture are known. The model contains a thin lens made by two standard surfaces and also simulates the principal planes. This model provides more accurate ray heights and it is aplanatic. Some design examples of an objective lens are also discussed in order to get a better understanding of design and optimization considerations.

CHAPTER 1. INTRODUCTION

1.1 The field of optical microscope lens objectives

Humans have always wanted to explore the unknown world since the beginning of history ^[1]. Roman people knew glass during 1st century AD. However, aberration correcting lenses were not widely used until spectacles were made in Italy at the end of the 13th century. The early "microscope" only contained magnifying glasses which had one power about 6x-10x. This kind of microscope was called "flea glasses" since it was used to look at some small insects like fleas. In the 1590s, two Dutch spectacle makers, Hans and Zacharias Janssen, created the first microscope, which was described as "composed of 3 sliding tubes, measuring 18 inches long when fully extended, and two inches in diameter" (shown in Figure 1.1). It had a magnification from 3x to 9x.



Figure 1.1 First microscope made by Hans and Zaccharias Janssen in 1590s.

Later in 1675, a Dutch draper and scientist, Antony Van Leeuwenhoek made himself a microscope with a power of 270x and observed bacteria (shown in Figure 1.2).



Figure 1.2 Microscope made by Anton van Leeuwenhoek in 1675.

With the study of optical principles, microscopes were improved rapidly from the middle of the 19th century to the 20th century. Recently, as the optical limits have been reached and the development of novel microscopes has slowed, more efforts are put into vision engineering to produce a user-friendly microscope.

A microscope is made not only to observe small objects in detail but also to give visibility to some tiny objects which may otherwise be invisible or unknown to us. The objective lens is one of the most significant parts among all the optical components in the microscope. When we use a microscope, the objective is at the nearest place from the object and forms an intermediate image, which can be magnified by eyepieces and produce a magnified image for people to observe. The objective lens determines how small of an object can be seen clearly through the microscope.

1.2 Goals of this thesis

This thesis includes two parts. The first part is an overview of microscope objectives, which discusses optical characteristics of microscope objectives and different types of objectives. The second part is a first order model of an objective, and some designs for an achromatic objective. The goals of these two parts are 1) to provide a brief overview of microscope objective technology and terms used in characterizing an objective, 2) to introduce a useful model to simulate first-order layouts of microscope objectives, 3) to illustrate some steps in the design and optimization of a microscope objective.

Many figures in this thesis are taken from the open literature and are acknowledged in the references section.

CHAPTER 2. MAIN CHARACTERISTICS OF MICROSCOPE OBJECTIVES

In this chapter, some main characteristics of the microscope objectives are introduced to 1) understand the meaning of an objective's markings, 2) have a brief overview of different characteristics of microscope objectives and microscopy technology.

2.1 Markings

Markings are usually printed outside of the objective. Some basic optical and mechanical specifications are indicated by words, numbers or colors. A 60x plan apochromatic objective shown in Figure 2.1 will be discussed as an example ^[2].



60x Plan Apochromat Objective

Figure 2.1 Objective Markings of a 60x Plan Apochromat Objective.

2.1.1 Manufacturer

Usually the manufacturer name will be written in the first line. Nikon is the manufacturer in Figure 2.1.

2.1.2 Objective Class

The second line shows the type of the objective. The objective is a plan apochromatic objective, which corrects flat-field and aberration. Some corrections and their abbreviations are in Table 1.

Table 1 aberration correction vs abbreviation.

Abbreviation	Туре
Achro, Achromat	Achromatic aberration correction
Fluor, Fl, Fluar, Neofluar, Fluotar	Fluorite aberration correction
Аро	Apochromatic aberration correction
Plan, Pl, Achroplan	Flat Field optical correction
EF, Acroplan	Extended Field (field of view less than Plan)
N, NPL	Normal field of view plan
Plan Apo	Apochromatic and Flat Field correction

2.1.3 Magnification & numerical aperture (NA)

Magnification and numerical aperture (NA) are in the third line. This objective has a magnification of 60x and an NA of 0.95. Manufactures always paint a colored circle which follows a color coding (shown in Figure 2.2) on the objective in order to estimate the magnification of an objective. The blue circle in Figure 2.1 shows that the magnification is between 40 to 63. Users can easily pull out the objective they want among a lot of different objectives based on the color coding ^[3].



Color Coding of Magnification:

Figure 2.2 color coding of magnification.

2.1.4 Contrast method

DIC (differential interference contrast) which is listed under the magnification, shows the contrast method of the objective. Sometimes the writing color of the markings also gives

the contrast method. For example, Zeiss makes its objectives markings written in different colors to distinguish the contrast method (shown in Figure 2.3).



Figure 2.3 Color of writing vs contrast method in Zeiss objectives.

2.1.5 Immersion fluid

Immersion fluid is used between object and the objective to enlarge NA and get a betterquality image. Immersion is usually printed after contrast method and follows the color coding of immersion fluid (Figure 2.4).

Immersion Fluid:



Figure 2.4 color coding of immersion fluid.

2.1.6 Tube length, cover glass thickness, working distance & correction collar

The tube length, cover glass thickness, working distance & correction collar specifications are in the fourth line. The tube length of the objective indicates whether it is finite conjugate or not, and the focal length of the objective if it is. In this case, the

objective is infinite conjugate hence the tube length is infinite. Cover glass thickness is between 0.11 mm -0.23 mm. The standard cover glass thickness is 0.17 mm. WD, (i.e. working distance) is 0.15 mm. Most objectives can adjust themselves by adjusting the correction collar to work with different cover glass thickness.

More details about these specifications are introduced later in this thesis in order to understand the markings.

2.2 Magnification

One of the most important characteristics is magnification. The magnification of a microscope is the product of the magnifications in the objective and the eyepiece ^[4], shown in Table 2.

Eyepiece	Objective Lens	Total Magnification
10X	4X	40X
10X	10X	100X
10X	40X	400X
10X	100X	1000X

Table 2 Magnification of eyepiece, objective and microscope.

With the same eyepiece, the larger the objective magnification is, the larger the microscope magnification will be. Magnification of an objective can range from 1x - 250x.

2.3 Resolution and numerical aperture (NA)

Resolution determines the ability of the objective to detect fine detail. There are three design characteristics of the objectives in order to set the resolution limit of the microscope: wavelength of object illumination light, refractive index in the object space and angular aperture of the light cone captured by the objective. In the diffraction-limited optical microscope, resolution is the minimum visible distance r between the two closest separate object points ^[5]. The relationship between wavelength, refractive index, insert light angle and resolution is shown in equation 1.

$$\mathbf{r} = \lambda/2\mathbf{n}\,\sin\mathbf{U}\tag{1},$$

In Eq. 1, r is the resolution, λ is the wavelength of insert light, n is the refractive index in the object space, U is the half angle of the light cone.

Eq. 1 can be written in a simpler way with the definition of numerical aperture (shown in Eq. 2).

Numerical Aperture (NA) =
$$n \sin U$$
 (2),

Hence the Eq. 1 can be rewritten as

$$\mathbf{r} = \lambda / (2 \text{ NA}) \tag{3},$$

A high NA is preferred in the objective to obtain a decent resolution.

2.4 Working distance

Working distance is the distance between the top of the cover glass or the object and the front surface of the objective front lens ^[6]. Working distance usually decreases as magnification increases, shown in Table 3.

Table 3 Objective magnification and working distance.

	Objective			
Property	Scanning	Low Power	High Power	Oil Immersion
Magnification	4X	10X	40-45X	90-100X
Working distance	17-20 mm	4-8 mm	0.5-0.7 mm	0.1mm

2.5 Entrance pupil and exit pupil location

Microscope objective is telecentric in object space, hence the entrance pupil is at infinity in image space and the exit pupil is at the front surface of the objective.

2.6 Cover glass

A proper cover glass can affect the image quality, especially for a high NA objective.

2.7 Immersion

Generally, there are three types of immersion: water, oil and glycerin. The refractive indices of immersions are different (Table 4) to achieve different NAs.

Material	Refractive Index
Air	1.0003
Water	1.333
Glycerin	1.4695
Paraffin oil	1.480
Cedar wood oil	1.515
Synthetic oil	1.515
Anisole	1.5178
Bromonaphthalene	1.6585
Methylene iodide	1.740

Table 4 The refractive indices of immersions.

2.8 Contrast enhancing

Sometimes the object or specimen cannot be observed easily due to its low contrast quality. Different methods are used to enhance the contrast, such as bright field, dark field, polarization, phase contrast, differential interference contrast (DIC) and Hoffman modulation ^[7]. Some examples are shown in Figure 2.5. Bright field, dark field and polarization are briefly introduced in this part.



Figure 2.5 Contrast-enhancing technologies in optical microscopy.

2.8.1 Bright field

Bright field, as its name indicates, is putting the incident light source under the object and condenser. Bright field is one of the primary and most common used techniques since the microscope was invented. It depends on refractive index, light absorption changes and color for generating contrast. Therefore, bright field is not suitable for unstained transparent objects. The numerical aperture of both the object and the condenser can affect the resolution in a bright field system.

2.8.2 Dark field

As for unstained transparent objects, the image will be bright and low-contrast if bright field is applied in the system. Adding a dark field patch stop between the incident light source and the condenser is the dark field illumination. The image is composed mostly of diffracted wave (shown in Figure 2.6). Dark field illumination is widely used in biological and medical fields.



Figure 2.6 Dark field microscope optical configurations.

2.8.3 Polarization

If the object is anisotropic, such as crystals, for which the refractive index depends on the vibration direction of the incident light, polarized light can improve the image quality dramatically. Two polarizing elements are placed in this method (Figure 2.7).



Figure 2.7 polarizing light microscope optical pathways.

The polarizer between the incident light source and the condenser makes linear polarized wavefront pass through the condenser and illuminate the object. The polarizer beneath the tube lens (analyzer) is rotated 90 degrees around the other polarizer. If there is no object, there will be no light passing through the tube lens. If an anisotropic object is placed, it will have different refractive indices when the light passes through. There is an optical path difference between the two wavefronts. Therefore, when the analyzer combines the two wavefronts again, the two wavefronts will have the same amplitude at the time of maximum contrast.

2.9 Tube length

If the tube length of an objective is finite, it is a finite optical system (shown in Figure 2.8 (a)). If the tube length of an objective is infinite, it is infinitely corrected and an infinite objective needs a tube lens between it and the eyepiece (shown in Figure 2.8 (b)).

Most available objectives now are infinite.



(b) Infinity optical system

Figure 2.8 Finite & infinity microscope optical system.

2.10 Type of objectives

Objectives have 2 main different types: refractive and reflective.

2.10.1 Reflective objective

The incident light passes through the optical system refracted by a series of optical lenses in refractive objectives. All elements are coated to reduce reflections and increase light throughout the rate. Reflective objectives are made to get high magnification and correct chromatic aberration from deep-ultraviolet to far-infrared light. Reflective objectives are mostly mirror-based designs. The most used type is two-mirror Schwarzschild objective (shown in Figure 2.9), which has a spider mount and two mirrors covered with coatings.



Figure 2.9 Schwarzschild objective.

2.10.2 Refractive objective

Most traditional microscopes use refractive objectives. There are different types of refractive objectives: achromatic, fluorite (semi-apochromatic), apochromatic and plan objectives. Each type has different aberration corrections (shown in Table 5).

Table 5 Objective type vs optical aberration correction.

Objective Type	Spherical	Chromatic	Field
	Aberration	Aberration	Curvature
Achromat	1 color	2 colors	No
Plan Achromat	1 color	2 colors	Yes
Fluorite	2-3 colors	2-3 colors	No
Plan Fluorite	3-4 colors	2-4 colors	Yes
Plan Apochromat	3-4 colors	4-5 colors	Yes

The chromatic aberration correction is one of the most important aberration corrections in the objectives. The material index is different due to the wavelength difference for the non-monochromatic light. Therefore, the focal length is not the same for different color. The chromatic aberration of a single lens is shown in Figure 2.10.



Figure 2.10 Chromatic aberration of a single lens.

The achromat lens is the simplest way for the objective to correct some aberrations.

2.10.2.1 Achromatic objective

The most common and least expensive refractive objectives are achromatic objectives (achromat). These objectives are made to correct axial chromatic aberration in two wavelengths, usually blue (486 nm) and red (656 nm), and cancel the distance between each focal point (shown in Figure 2.11).



Figure 2.11 Chromatic aberration correction of an achromat.

Furthermore, the achromatic objective corrects spherical aberration for green light (546 nm), hence a green filter (interference filter) can be used to get a better image. The center of the achromatic objective is focused, but the edge of the objective may not be. For most

purposes, it can produce an adequate result, when objective requires focused lens periphery (i.e. correct field curvature), plan achromatic objective is needed.

2.10.2.2 Fluorite (semi-apochromatic) objective

The second type of objective is fluorite or semi-apochromatic, which was used for mineral fluorite. Fluorite objectives not only correct axial chromatic aberration in blue and red lights, but also provide spherical aberration correction for two or three colors.

Fluorite objectives have better resolution and higher NAs compare to achromatic objectives, hence they are more expensive as well. They are widely used for fluorescence observation. Plan fluorites are also made to correct field curvature.

2.10.2.3 Apochromatic objective

The third type is apochromatic objectives, which are the most expensive and highly corrected among these three types of objectives. Apochromatic objectives are corrected chromatically for three colors (red, green and blue) (shown in Figure 2.12), and provide spherical aberration correction for two or three colors as are fluorites.



Figure 2.12 Chromatic aberration correction of an apochromatic objective.

Apochromatic objectives can be used for color photomicrography in white light because they almost eliminate chromatic aberration and have higher numerical aperture for the same magnification compared to achromatic and fluorite objectives. Plan apochromatic objectives are the most complex and expensive objectives which correct chromatic aberration and field curvature within the objective itself.

2.11 Image quality

The image provided by the microscope needs to be as accurate as possible with aberration (spherical and chromatic aberration) and spurious detail removed. Most microscope objectives now are fully corrected and eyepieces or tube lenses are free from additional correction.

2.12 Mechanical dimensions

The mechanical data sheet is needed to choose the correct objective for a microscope tube. It includes diameters and lengths of each part. Figure 2.13 is the mechanical dimensions of a Zeiss 40x plan-apochromat objective. The diameters, lengths and object plan can be found out easily in this figure.



Figure 2.13 Mechanical dimensions for a Zeiss plan-apochromat objective.

2.13 Vendors:

There are many microscope objective vendors around the world. Some of the most famous ones are Zeiss, Nikon, Edmund, Olympus etc.

CHAPTER 3. FIRST ORDER MODELING OF AN OBJECTIVE

In order to analyze a microscope, sometimes it is necessary to have a simple model for the objective lens. This is because the detailed specifications of a microscope objective are not always known; for instance, the surface radii, distances between surfaces and refraction indices may not be provided. In this chapter, three different and simple models for a microscope objective lens are discussed to get a better understanding of the microscope objective. Zemax Optics Studio lens design program is used to build the models to simulate the objective lens and system^[8]. The infinity- corrected objective is chosen to be simulated, since it is widely used in industrial microscopes. The models have two parts, an objective and a tube lens. The object was placed at the front focal plane of the objective, so the light bundle was parallel after passing through the objective for one object point. An intermediate image was formed after the light went through the tube lens which was placed between the objective and the eyepiece. The intermediate image should be at the rear focal plane of the tube lens which is at a finite distance within the microscope tube. The infinity-corrected optical system is a telecentric system in object space. The magnifying power of this system is the focal length of the tube lens divided by the focal length of the objective.

The three models are a) paraxial surface in Zemax Optics Studio, b) standard surface, and c) standard surface with principal plane thin lens model. These models are used to simulate an objective which has the magnification of 20x and object space Numerical Aperture (NA) of 0.75. The objective has 5-mm focal length and the tube lens has 100mm focal length in each model.

3.1 Paraxial surface thin lens model

Firstly, consider the objective and tube lens are two single thin lenses with 0 mm thickness. Assuming the system traces rays in very small heights and angles, it can follow the paraxial approximation (small-angle approximation). When angle θ and θ ' are small enough ($\theta < 0.2$ in radians) then there is Eq. 4.

$$\sin \theta \sim= \theta,$$

$$\sin \theta' \sim= \theta'.$$
 (4)

For Snell's law,

$$n\sin\theta = n'\sin\theta', \qquad (5)$$

can be approximated as

$$\mathbf{n} \,\boldsymbol{\theta} = \mathbf{n}' \,\boldsymbol{\theta}'. \tag{6}$$

The paraxial surface in Zemax Optics Studio can be used as the objective.

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12/16/2016 Total Axial Length: 210.00000 mm	Zemax Zemax OpticStudio 15.5 SP3
	1 order model_ideal.ZMX Configuration 1 of 1

Figure 3.1 Lay out of the paraxial surface thin lens model.

The layout of this system is in Figure 3.1. Both objective and tube lens are paraxial thin lenses. The objective has 5 mm focal length and the object is placed at the front focal plane of this thin lens. The system stop is at the rear focal plane of the objective. The incident light passes through the objective and the intermediate image plane is at infinity. The tube lens is placed 100 mm behind the stop. The image is 100 mm behind the tube lens since the tube lens has 100 mm focal length. Both lens data and system data are listed in Figure 3.2. The paraxial image height is 2 mm when the object height is 0.1 mm, which achieved the magnification of 20x.

1	Sui	rf:Type	Comment	Radius	Thickness	Material	Coating	Semi-Diameter	Chip Zone	Mech Semi	Conic	Focal Length
C	OBJECT	Standard •		Infinity	5.000			0.100	0.000	0.100	0.0	
1		Paraxial 🔻	objective		0.000			5.769	-	-		5.000
2	:	Standard 🔻		Infinity	5.000			5.769	0.000	5.769	0.0	
3	STOP	Standard -	rear focal pla	Infinity	100.000			5.669	0.000	5.669	0.0	
4		Paraxial 🔻			100.000			7.669	-	-		100.000
5	IMAGE	Standard •		Infinity	-			2.000	0.000	2.000	0.0	

Effective Focal Length	:	1e+10	(in air at system temperature and pressure)
Effective Focal Length	:	1e+10	(in image space)
Total Track	:	205	
Image Space F/#	:	0.4409586	
Paraxial Working F/#	:	8.819171	
Working F/#	:	8.833333	
Image Space NA	:	0.05660377	
Object Space NA	:	0.75	
Stop Radius	:	5.669467	
Paraxial Image Height	:	2	
Paraxial Magnification	:	-20	
Entrance Pupil Diameter	:	2.267787e+10	
Entrance Pupil Position	:	1e+10	
Exit Pupil Diameter	:	1.133893e+09	
Exit Pupil Position	:	1e+10	
Field Type	:	Object height in	Millimeters
Maximum Radial Field	:	0.1	
Primary Wavelength [µm]	:	0.5875618	
Angular Magnification	:	-0.04999993	

Figure 3.2 Lens data and system data of the paraxial surface thin lens model.

2: Seidel Diagra	m						C	
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Grid lines are sp	aced 0.00020	Millimeters.			1 ord Con	ler model figuratio	_ideal.ZMX	

Figure 3.3 Aberration Seidel Diagram of the paraxial surface thin lens model.

There are no aberrations as shown in the Seidel diagram (shown in Figure 3.3), which is reasonable for a paraxial thin lens model. Realistically, an objective lens may have more aberrations, such as spherical aberration, field curvature and astigmatism. The model uses a paraxial surface as the thin lens, which is not suitable for the microscope objective. Also, this model is not ideal for us to discuss numerical aperture (NA).



Figure 3.4 Sketch of the objective in the paraxial surface thin lens model.

From the system data, we noticed the stop radius is 5.669467 mm while object space NA= 0.75 and f= 5 mm. Obviously for the maximum half angle of the insert light, θ (shown in Figure 3.4), with the small angle approximation,

$$\tan \theta = \text{stop radius/ } f = 1.1338934. \tag{7}$$

 θ = 48.59037741 or 0.84806207 rad, indicates that NA cannot be assumed as n θ . The object space NA is not accurate in this model. We can't use the paraxial thin lens because incident light angle is not small enough for paraxial ray-tracing. Another disadvantage of this model is that NA can't be calculated directly by the stop radius and the distance between the object and the objective.

To solve this problem, the paraxial surface can be replaced by the standard surfaces (shown in Figure 3.5). The first standard surface of the objective has radius curvature r = f, so that

NA=nsin
$$\theta$$
= stop radius/ r= stop radius/ f. (8)



Figure 3.5 Sketch of the objective in the standard thin lens model.

3.2 Standard surface thin lens model

With the need of having a more accurate object space NA, the standard surface can be used in the system instead of the paraxial surface. In order to make a thin lens to be the objective, two or more standard surfaces are needed. Since this is a first order model, two standard surfaces are made to simulate the thin lens. The first surface has -5 mm radius so that the object is placed at the center point of the first standard surface as well as the front focal point of the thin lens. The objective space NA= nsin θ = stop radius/ r= stop radius/ f. The layout of the standard surface thin lens model is in Figure 3.6.



Figure 3.6 Layout of the standard surface thin lens model.

	Sur	f:Type	Comment	Radius	Radius		s Material	Material		Semi-Diameter	
0	OBJECT	Standard 🔻		Infinity		5.000				0.100	
1		Standard 🔻	objective front surface	-5.000		0.000	-10000.00,0.0	۷		3.793	
2		Standard 🔹	objective back surface	-5.000		5.000				3.794	
3	STOP	Standard 🔻	rear focal plane	Infinity		100.000				3.836	
4		Paraxial 🔻	second lens			100.000				5.789	
5	IMAGE	Standard 🔹		Infinity		-				2.051	
			1								

The lens data is listed in Figure 3.7.

Effective Focal Length	:	1e+10
Effective Focal Length	:	1e+10
Back Focal Length	:	1.295872e+14
Total Track	:	205
Image Space F/#	:	0.4409586
Paraxial Working F/#	:	8.819171
Working F/#	:	13.34134
Image Space NA	:	0.05660377
Object Space NA	:	0.75
Stop Radius	:	5.669467
Paraxial Image Height	:	2
Paraxial Magnification	:	-20
Entrance Pupil Diameter	:	2.267787e+10
Entrance Pupil Position	:	1e+10
Exit Pupil Diameter	:	1.133893e+09
Exit Pupil Position	:	1e+10

(in air at system temperature and pressure) (in image space)

Figure 3.7 Lens data and system data of the standard surface thin lens model.

The distance between the center of the two standard surfaces is 0 mm. The first surface has a radius of -5 mm, while the second surface has -5.0005 mm radius. Therefore, a thin lens is built, and since the focal length of the thin lens needs to be 5 mm, the index between the two surfaces should be variable to achieve the 5-mm focal length. The index between the two lenses is -10000.0000002 after optimized. Obviously, this index is not commonly used in an actual objective, but the high index allows the model to simulate an aplanatic lens. The equivalent refracting surface of an aplanat is spherical. The stop radius is 3.836 mm. If the equation NA=nsin θ = stop radius/r is used here, object space NA= 3.836/ 5= 0.7672, which is very close to the desired value of NA= 0.75. The focal

length is the distance between the focal point and the principal point according to

Gaussian optics.



Figure 3.8 Aberration Seidel Diagram of the standard surface thin lens model.

There is no coma and nearly zero spherical aberration by construction. It mainly has astigmatism, distortion as shown on the Seidel diagram in Figure 3.8.

Furthermore, the lenses with thickness are needed in the actual objective. The objects are placed at the focal plane. If an objective is simulated by a first order model, the principal planes must be added. The third model is introduced next in order include the principal plane separation.

3.3 Thin lens with principal plane model

Once the principal planes separation is known, the lens system can be simplified as a single lens with principal planes. If we use thick lenses in modelling, we may not easily find the principal plane to determine the place of the focal point and the object. Therefore, the thin lens with principal plane model are built to simulate this objective.

A ray emerges from the lens and crosses the rear principal plane at the same height as the same ray appeared to cross the front principal plane. A relay lens set with the magnification of 1x can be used as the principal planes (shown in Figure 3.9).



Figure 3.9 Principal planes detail (Chief and Marginal ray only).

The highlighted standard surface with infinity radius can be used as front principal plane. The last standard surface with infinity radius on the right is the rear principal

plane. Seven surfaces (including 4 paraxial thin lenses with -1x magnification and 3 standard surfaces with infinity radius) are separated equally between two principal surfaces. When the parallel light bundles pass through the first paraxial thin lens, they focus on the rear focal point of the first paraxial thin lens as well as the front focal point of the second paraxial thin lens. Then the light bundles become parallel again with the opposite height. After passing through another same lens set, the light bundles are still parallel and have the same height as the highlight standard surface after they pass through the fourth paraxial thin lens and the last standard surface. A lay out of the whole system is clearer after hiding all the surfaces between two principal planes and the rays to these surfaces (shown in Figure 3.10).



Figure 3.10 Lay out of thin lens with principal plane model.

The thicknesses of these surfaces can be set as pickup in Zemax, which are all equal to divide the distance between the two principal planes by 8. We set the distance to be 5 mm, so the thicknesses are 0.625 mm (shown in Figure 3.11). The index of lens material is positive, which is acceptable for the thin lens model. The ray heights in the model are also simulated properly. The stop radius is 3.75 mm. The object space NA= stop radius/ focal length, or NA= 3.75/5= 0.75 in this case, which is the most accurate one among these three models.

	Surf:Type	Comment	Radius	Thickness	Material	Coating	Semi-Diameter	Chip Zone	Mech Semi-Dia	Conic
0	OBJECT Standard 🔻	Front Focal P	Infinity	0.000			0.100	0.000	0.100	5.000
1	Standard 🔻		Infinity	5.000			0.100	0.000	0.100	0.000
2	Standard 🔻	Objective	-5.000	0.000	100000.00,0.0		3.891	0.000	3.891	0.000
3	Standard 🔻	Objective	-5.000	0.000			3.891	0.000	3.891	0.000
4	Standard 🔻	Front PP	Infinity	0.625 P			3.853	0.000	3.853	0.000
5	Paraxial 🔻			0.625 P			3.840	-	-	
6	Standard 🔻		Infinity	0.625 P			0.013	0.000	0.013	0.000
7	Paraxial 🔻			0.625 P			3.866	-	-	
8	Standard 🔻		Infinity	0.625 P			3.853	0.000	3.853	0.000
9	Paraxial 🔻			0.625 P			3.840	-	-	
10	Standard 🔻		Infinity	0.625 P			0.013	0.000	0.013	0.000
11	Paraxial 🔻			0.625 P			3.866	-	-	
12	Standard 🔻	Rear PP	Infinity	5.000			3.853	0.000	3.853	0.000
13	STOP Standard •	Rear Focal P	Infinity	100.000			3.750	0.000	3.750	0.000
14	Paraxial 🔻	Second lens		100.000			5.700	-	-	
15	IMAGE Standard -		Infinity	-			2.060	0.000	2.060	0.000

Effective Focal Length	:	-1.01495e+07
Effective Focal Length	:	-1.01495e+07
Back Focal Length	:	2.029926e+08
Total Track	:	215
Image Space F/#	:	8.819231
Paraxial Working F/#	:	8.819258
Working F/#	:	13.34306
Image Space NA	:	0.05660322
Object Space NA	:	0.75
Stop Radius	:	-5.669411
Paraxial Image Height	:	2.00002
Paraxial Magnification	:	-20.0002
Entrance Pupil Diameter	:	1150838
Entrance Pupil Position	:	-507471.7
Exit Pupil Diameter	:	7.499742e+08
Exit Pupil Position	:	1e+10

(in air at system temperature and pressure) (in image space)

Figure 3.11 Lens data and system data of thin lens with principal plane model.



Figure 3.12 Aberration Seidel diagram of thin lens with principal plane model.

From the aberration Seidel diagram (shown in Figure 3.12), it is easy to figure out that the lens system mainly has astigmatism. The spherical aberration is quite small compared to the other two models, which is great to simulate an aplanatic objective.

3.4 Conclusion

The comparison of these 3 models is summarized in table 6:

Table. 6 Comparison of 3 first order models.

	Advantages	Disadvantages
Paraxial thin lens	Easy to build	Non-accurate marginal ray
	No aberration	height and numerical aperture
Standard surface	Easy to build	No principal planes and does
thin lens		not simulate thick lens
		Aplanatic by construction
Thin lens with	Accurate numerical aperture	It uses several surfaces
principal plane	Aplanatic as real objective	
	Easy to determine focal plane	
	when simulating a thick lens	

The comparison in the Table 6 indicates that the thin lens with principal plane is the best first order model of simulating a microscope objective.

CHAPTER 4. DESIGN EXAMPLES

Some design examples are discussed in this chapter to illustrate some steps in the design and optimization of a microscope objective.

4.1 Achromatic objective

In this section, an achromatic doublet is used as a finite conjugate achromatic objective.

A 4x/0.1 objective model is built. Set the optical tube length (OTL) as 170 mm, which means the image plane of this objective is at 170 mm behind the rear focal plane as well as the stop plane. The object is placed at the front focal plane of the objective in a microscope. The focal length of the objective follows equation 9:

$$f = d/M_0, \tag{9}$$

f is the focal length of the objective, d is OTL, M_o is the magnification of the objective.

However, the object plane is not easy to figure out in the model built in Zemax since the principal plane is not known in this optical system and the distance between the object and the first surface of the achromat is not accurate.

Therefore, the whole system can be flipped around in order to make the model clearer. The image plane of the objective can be set as the object plane.

It is obvious that the distance between the object and the stop is fixed as 170 mm. The stop should be at the front focal plane of this achromat and the location of the principal plane is unknown, so it is set to be a variable. The achromat is a doublet which contains a

2-mm thick concave lens (made of flint glass) and a 6-mm thick convex lens (made of crown glass). F2 and BK7 are chosen to be the materials of the achromat. Paraxial image height is chosen to be 1 mm in the field data to let the system be close to the objective with a 1-mm object. When NA is 0.1 for the objective, the image space NA is 0.1 in this system. The image space F/# is chosen as the aperture type, because:

$$F/\# \sim = 1/(2 \text{ NA}),$$
 (10)

The image space F/#= 1/(2*0.1) = 5. The lens data of the model is shown in Figure 4.1 after optimizing the system.

	Sur	f:Type	Comment	Radius	Thickne	ss Material	Coating	Clear Semi-Dia	Chip Zone	Mech Semi-Dia	Conic	TCE x 1E-6
0	OBJECT	Standard 🔻		Infinity	170.000			3.993	0.000	3.993	0.0	0.000
1	STOP	Standard 🔻		Infinity	42.327	V		4.254	0.000	4.254	0.0	0.000
2	(aper)	Standard 🔻		20.132 V	2.000	N-F2	TH	8.000 U	0.000	8.000	0.0	-
3	(aper)	Standard 🔻		10.243 V	6.000	N-BK7		8.000 U	0.000	8.000	0.0	-
4	(aper)	Standard 🔻		-188.753 V	47.995	V	TH	8.000 U	0.000	8.000	0.0	0.000
5	IMAGE	Standard 🔻		Infinity	-			1.047	0.000	1.047	0.0	0.000

Figure 4.1 Lens data of the achromat (a).

The semi-diameter of the image is 1.047 mm and the semi-diameter of the object is 3.993 mm. The actual magnification is close to the ideal magnification 4x. The image space NA is 0.09942713 and the effective focal length (EFFL) is 42.53994 mm in the system data (Figure 4.2).

Effective Focal Length	:	42.53994	(in ai	ir at syst	em	temperature	and	pressure)
Effective Focal Length	:	42.53994	(in in	nage space	2)			
Back Focal Length	:	37.37151						
Total Track	:	98.32226						
Image Space F/#	:	5						
Paraxial Working F/#	:	5.00389						
Working F/#	:	5.004417						
Image Space NA	:	0.09942713						
Object Space NA	:	0.02501566						
Stop Radius	:	4.253994						
Paraxial Image Height	:	1						
Paraxial Magnification	:	-0.2504296						
Entrance Pupil Diameter	:	8.507988						
Entrance Pupil Position	:	0						
Exit Pupil Diameter	:	2738.621						
Exit Pupil Position	:	-13703.73						
Field Type	:	Paraxial Image height	t in M	Millimeter	٦S			
Maximum Radial Field	:	1						
Primary Wavelength [µm]	:	0.5876						
Angular Magnification	:	0.003106781						
Lens Units	:	Millimeters						

Figure 4.2 System data of the achromat (a).

The layout of the system is in Figure 4.3.



Figure 4.3 Layout of the achromat (a).

However, the chromatic focal shift (shown in Figure 4.4) is not right for an achromat. Two different colors can focus on the same focal point after passing through an achromat. It should be a "c" shape in the chromatic focal shift diagram ^[9].



Figure 4.4 The chromatic focal shift of the achromat (a).

The Seidal diagram (Figure 4.5) also shows that the system has some spherical aberration and axial color.



Figure 4.5 Seidel diagram of the achromat (a).

The merit function should be used to cancel some focal shift. The operand AXCL with the target of 0 is added in order to control the focal shift (Figure 4.6).

	Туре	Wave1	Wave	Zoi						Target	Weight	Value	% Contrib	
1	RAID 🕶	5	2	0	1	0	0			0.000	10.000	0.000	0.000	^
2	EFFL 🔻		1							42.500	100.000	0.000	100.000	
3	AXCL 🕶	0	2	0						0.000	0.000	0.000	0.000	
4	DMFS▼	DMFS -												
5	BLNK 🕶	Default mer	it functi	on: R	MS v	vavef	ront	chief	GQ	8 rings 1	0 arms			
6	BLNK 🕶	No default a	o default air thickness boundary constraints.											
7	BLNK 🕶	No default o	o default glass thickness boundary constraints.											
8	BLNK 🕶	Operands for	erands for field 1.											

Figure 4.6 Merit function of the achromat (a).

When the weight of an operand is higher than others, Zemax is more likely to meet the requirement of this operand when it is optimizing the system. If the AXCL has a weight of 100, the focal shift (Figure 4.7) is much better than before ^[10].



Figure 4.7 The chromatic focal shift of the achromat (b).



There is almost no axial color in the Seidel diagram (Figure 4.8).

Figure 4.8 Seidel diagram of the achromat (b).

However, this system is not perfect as well. The image space NA is not as good as it was in the model before adding the AXCL operand (shown in Figure 4.9).

Effective Focal Length	:	42.48014	(in air at system	temperature	and	pressure)
Effective Focal Length	:	42.48014	(in image space)			
Back Focal Length	:	35.83925				
Total Track	:	97.61677				
Image Space F/#	:	5				
Paraxial Working F/#	:	5.031219				
Working F/#	:	5.029185				
Image Space NA	:	0.09889234				
Object Space NA	:	0.02498052				
Stop Radius	:	4.248014				
Paraxial Image Height	:	1				
Paraxial Magnification	:	-0.2514434				
Entrance Pupil Diameter	:	8.496028				
Entrance Pupil Position	:	0				
Exit Pupil Diameter	:	342.1404				
Exit Pupil Position	:	-1721.407				
Field Type	:	Paraxial Image heig	ht in Millimeters			
Maximum Radial Field	:	1				
Primary Wavelength [µm]	:	0.5876				
Angular Magnification	:	0.02483218				
Lens Units	:	Millimeters				

Figure 4.9 System data of the achromat (b).

The image NA is 0.9889234, which is less than the image NA in the last model.

The result may be different if the achromat has the convex lens in the front, by setting the thickness of the second surface as 6 mm and the thickness of the third surface as 2 mm. The materials are also exchanged. The layout of the system is in Figure 4.10.



Figure 4.10 Layout of the achromat (c).

The radius of each surfaces is different from the models above (Figure 4.11).

	Sur	f:Type	Comment	Radius	Thickne	ess	Material	Coatin	g	Clear Semi-Dia	Chip Zon	e Mech Semi-Dia	Conic	TCE x 1E-6
0	OBJECT	Standard 🔻		Infinity	170.000					3.996	0.000	3.996	0.0	0.000
1	STOP	Standard 🔻		Infinity	41.434	V				4.248	0.000	4.248	0.0	0.000
2	(aper)	Standard 🔻		23.347 \	6.000		BK7	TH		8.000 l	J 0.000	8.000	0.0	-
3	(aper)	Standard 🔻		-14.431 \	2.000		F2			8.000 l	J 0.000	8.000	0.0	-
4	(aper)	Standard 🔻		-69.790 \	48.668	V		TH		8.000 l	J 0.000	8.000	0.0	0.000
5	IMAGE	Standard 🔻		Infinity	-					1.044	0.000	1.044	0.0	0.000

Figure 4.11 Lens data of the achromat (c).

The focal shift is better than the last model (Figure 4.12).



Figure 4.12 Focal shift of the achromat (c).

The spherical aberration is much smaller compared to other models as well based on the Seidel diagram (Figure 4.13).



Figure 4.13 Seidel diagram of the achromat (c).

The image space NA is 0.09934623 (Figure 4.14). This system has a better image

Effective Focal Length	:	42.47539 (in air at system	temperature	and pressure)
Effective Focal Length	:	42.47539 (in image space)		
Back Focal Length	:	37.93777			
Total Track	:	98.10193			
Image Space F/#	:	5			
Paraxial Working F/#	:	5.008006			
Working F/#	:	5.003566			
Image Space NA	:	0.09934623			
Object Space NA	:	0.02497773			
Stop Radius	:	4.247539			
Paraxial Image Height	:	1			
Paraxial Magnification	:	-0.2502553			
Entrance Pupil Diameter	:	8.495077			
Entrance Pupil Position	:	0			
Exit Pupil Diameter	:	1327.815			
Exit Pupil Position	:	-6649.807			
Field Type	:	Paraxial Image height	in Millimeters		
Maximum Radial Field	:	1			
Primary Wavelength [µm]	:	0.5876			
Angular Magnification	:	0.006397932			
Lens Units	:	Millimeters			

space NA than the models above.

Figure 4.14 System data of the achromat (c).

In fact, the model above is the most common achromat type. The crown glass BK7 is in the front and the flint glass F2 is in the back. BK7 and F2 may not be the best solution for the achromat as long as other types of glass work better. The solve type of the materials can be changed to substitute. Zemax will search for the best material after using hammer optimization. For instance, BALKN3 and SF3 work better in this system. However, the materials, which are used in the objective lens may not be the best combination. The cost of the material is also a significant consideration when it comes to manufacture objectives. The advantages and disadvantages of the three simulation models are summarized in Table 7, and the achromat (c) BK7-F2 model is the best among the three models in this chapter.

	Advantages	Disadvantages
(a) F2-BK7	More accurate image space NA and EFFL	Not aplanatic More chromatic aberration
(b) F2-BK7 with AXCL	More accurate EFFL Less chromatic aberration	Not aplanatic Less accurate image space NA
(c) BK7-F2 with AXCL	Most accurate image space NA; Less chromatic aberration; Aplanatic	

Table 7 Comparison of three achromatic objective models.

Besides the comparison of the three achromat models, there is another comparison to do. Since there is a first order model in chapter 3 which supposed to be able to simulate different kinds of objectives, let's try to convert the achromat (c) model to a first order model and compare them as well.

From the cardinal points data (Figure 4.15), the actual front principal plane is at 42.203630 mm behind surface 1 and the distance between the rear principal plane and surface 5 is 53.205710 mm. The distance between surface 1 and 5 is 98.10193 mm based on the system data. Therefore, the distance between these two principal planes is 98.10193-42.203630-53.205710 = 2.69259 mm.

Starting surface	: 1
Ending surface	: 5
Wavelength	: 0.587600
Orientation	: Y-Z
Lens units	: Millimeters

Object space positions are measured with respect to surface 1. Image space positions are measured with respect to surface 5. The index in both the object space and image space is considered.

	Object Space	Image Space
:	-42.475385	42.475385
:	-0.271755	-10.730325
:	42.203630	-53.205710
:	-42.747140	31.745060
:	42.203630	-53.205710
:	-42.747140	31.745060
	: : : : : : : : : : : : : : : : : : : :	Object Space : -42.475385 : -0.271755 : 42.203630 : -42.747140 : 42.203630 : -42.747140

Figure 4.15 Cardinal points data of achromat (c).

Therefore, the lens data of the first order model can be set as Figure 4.16.

	Surf:Type	Comment	Radius	Thicknes	s M	aterial	Coati	ng	Semi-Diameter	Chip Zone	Mech Semi-Dia	Conic	TCE x 1E-6	Focal Length
0	OBJECT Standard 🕶		Infinity	170.000					4.003	0.000	4.003	2.693	0.000	
1	STOP Standard •	Front FP	Infinity	42.500					4.248	0.000	4.248	0.000	0.000	
2	Standard 🔻	Front PP	Infinity	0.337	Р				6.310	0.000	6.310	0.000	0.000	
3	Paraxial 🔻			0.337	Р				6.327	-	-		0.000	0.337 P
4	Standard 🔻		Infinity	0.337	Р				0.016	0.000	0.016	0.000	0.000	
5	Paraxial 🔻			0.337	Р				6.294	-	-		0.000	0.337 P
6	Standard 🔻		Infinity	0.337	Р				6.310	0.000	6.310	0.000	0.000	
7	Paraxial 🔻			0.337	Р				6.327	-	-		0.000	0.337 P
8	Standard 🔻		Infinity	0.337	Р				0.016	0.000	0.016	0.000	0.000	
9	Paraxial 🔻	Rear PP		0.337	Р				6.294	-	-		0.000	0.337 P
10	Standard 🔻		42.500	0.000	1000	0.00,0.0	N		6.333	0.000	6.333	0.000	0.000	
11	Standard 🔻		42.504	0.000					6.333	0.000	6.333	0.000	0.000	
12	Standard 🔻		Infinity	53.091	M				6.382	0.000	6.382	0.000	0.000	
13	IMAGE Standard -		Infinity	-					1.006	0.000	1.006	0.000	0.000	

Figure 4.16 Lens data of the converted first order model for achromat (c).

The achromat is converted as two principal planes (surface 2 to surface 9) and a thin lens (surface 10 and surface 11). The distance between surface 2 and surface 9 is 2.69259 mm, 3 standard surfaces and 4 thin lenses are equally separated between surface 2 and 9 to simulate the principal planes. The focal length of these 4 thin lenses is 2.69259/8= 0.336574 mm. The thin lens which locates at the rear principal plane has a focal length of 42.5 mm by setting the radius of surface 10 as 42.5 mm and the radius of surface 11 as 42.504253 mm. The layout of the system is in Figure 4.17.

Figure 4.17 Layout of the converted first order model for achromat (c).

Effective Focal Length	:	42.47852 (in a	air at system	temperature	and	pressure)
Effective Focal Length	:	42.47852 (in :	image space)			
Back Focal Length	:	42.47852					
Total Track	:	98.28403					
Image Space F/#	:	5					
Paraxial Working F/#	:	4.999368					
Working F/#	:	4.96977					
Image Space NA	:	0.09951617					
Object Space NA	:	0.02497957					
Stop Radius	:	4.247852					
Paraxial Image Height	:	1					
Paraxial Magnification	:	-0.2498421					
Entrance Pupil Diameter	:	8.495704					
Entrance Pupil Position	:	0					
Exit Pupil Diameter	:	16796.7					
Exit Pupil Position	:	83972.91					
Field Type	:	Paraxial Image height	: in	Millimeters			
Maximum Radial Field	:	1					
Primary Wavelength [µm]	:	0.5875618					
Angular Magnification	:	-0.0005056906					
Lens Units	:	Millimeters					

Figure 4.18 System data of the converted first order model for achromat (c).

The effective focal length is 42.47852 mm and the image space NA is 0.09951617 based on the system data in Figure 4.18.

System data	Actual achromat (c)	First order model of
		achromat (c)
Effective focal length	42.47539 mm	42.47852 mm
Total Track	98.10193 mm	98.28403 mm
Working F/#	5.003566	4.96977
Image Space NA	0.09934623	0.09951617
Paraxial Magnification	-0.2502553	-0.2498421
Entrance Pupil Diameter	8.495077 mm	8.495704 mm

Table 8 Comparison between the actual achromat model and the first order model.

The system data of the two models are close enough (shown in Table 8) to prove that the first order model can be used to simulate the 4x/0.1 achromatic objective lens.

CHAPTER 5. CONCLUSION

In this thesis, an overview of microscope objectives is summarized in chapter 1 and 2, including a brief review of the microscope history and some specifications and characteristics of microscope objectives. Users can choose the objective they need after understanding the meaning of the markings written/ painted on the objective barrel. The characteristics determine the performance of the objective. There are two types of the objective: refractive and reflective. The most used are refractive objectives and include achromat, plan achromat, fluorite, plan fluorite and plan apochromat. Plan apochromat corrects field curvature as well as spherical and chromatic aberration. In chapter 3, three first order models are built to simulate an infinity corrected objective; the only known specifications are magnification and NA. The third model which has standard surfaces and principal planes is the best one to simulate an objective because it provides proper ray heights. The objective model is aplanatic as well. This model can simulate any kind of objective without knowing the surface radius or the materials. In chapter 4, three models are built and optimized in order to find out a better solution for a finite 4x/0.1achromatic objective. The achromat, which has the convex lens in the front and the concave lens at the back, corrects more aberration than the one with a concave lens in the front. These models illustrate some steps of optical design and optimization.

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